



HJW/S
PATENT

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicants: Mun et al.

Serial No.: 10/699,438

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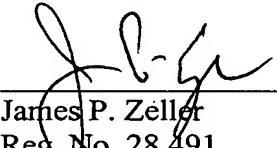
For: SILICON WAFERS AND
METHOD OF FABRICATING THE
SAME

Group Art Unit: 2822

Examiner: Maria F. Guerrero

I hereby certify that this paper (or fee) is being deposited with the United States Postal Service, first class postage prepaid, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

September 13, 2005


James P. Zeller
Reg. No. 28,491

AMENDMENT "A"

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

the amendments to the claims section begins on page 2 of this paper; and

the remarks begins on page 6 of this paper.